



DoCKET No. 378-21-011

EXPRESS MAIL LABEL NO. EV229157209US
PATENT

Applicants: Craig A. Vincze, et al.

Serial No.: 10/608,731

Art Unit: 2869

Filed: June 27, 2003

Title: MASS FLOW METER WITH CHIP TYPE SENSORS

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

TRANSMITTAL FOR INFORMATION DISCLOSURE STATEMENT

Sir:

Enclosed is an Information Disclosure Statement for the above application. Applicant is a small entity. We authorize the Commissioner to charge payment of any additional fees required in connection with this application to Deposit Account No. 11-1580. We enclose a copy of this sheet.

Respectfully submitted,



Richard S. Koppel
Registration No. 26,475
Attorney for Applicant

October 6, 2003

KOPPEL, JACOBS, PATRICK & HEYBL
555 St. Charles Drive, Suite 107
Thousand Oaks, California 91360
(805) 373-0060

SD1\HEETRONIX\378-21-011 IDS TRANS.

CERTIFICATE OF MAILING UNDER 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as Express Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia, 22313-1450 on the date shown below:

October 6, 2003 

Date

Stephanie A. Eisel



BUCKET NO. 378-21-011

EXPRESS MAIL LABEL NO. EV229157209US
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Craig A. Vincze, et al.

Serial No.: 10/608,731

Art Unit: 2869

Filed: June 27, 2003

Title: MASS FLOW METER WITH CHIP TYPE SENSORS

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Enclosed is PTO Form 1449 (and copies of non-U.S. references) for this application. The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability, or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

Respectfully submitted,

Richard S. Koppel
Registration No. 26,475
Attorney for Applicant

October 6, 2003

KOPPEL, JACOBS, PATRICK & HEYBL
555 St. Charles Drive, Suite 107
Thousand Oaks, California 91360
(805)373-0060
S:\R\HEETRONIX\378-21-011 IDS 1

FORM PTO-1449 (Modified)	Docket No. 378-21-011	Application Number 10/608,731
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	Applicant: Craig A. Vincze, et al.	
Use several sheets if necessary)	Filing Date 06/27/2003	Group Art Unit 2829

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

	Document Number							Date	Country	Class	Subclass	Translation	
												Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	A.	WORKSHOP ON MASS FLOW MEASUREMENT AND CONTROL FOR THE SEMICONDUCTOR INDUSTRY, NATIONAL INST. OF STANDARDS AND TECHNOLOGY, 15-16 MAY 2000, PAGES 1-26
	B.	"HOW TO MONITOR MASS FLOW", PRECISION FLOW DEVICES, INC., CUSTOMER PRESENTATION, 1985. (The year of publication is sufficiently earlier than the effective filing date and any foreign priority date.)
j	C.	CORTE SWEARINGEN, "CHOOSING THE BEST FLOWMETER, COLE-PARMER INSTRUMENT CO., REPRINT FROM CHEMICAL ENGINEERING, JULY 1999
	D.	CORTE SWEARINGEN, "SELECTING THE RIGHT FLOWMETER-PART 2", COLE-PARMER INSTRUMENT CO REPRINT FROM CHEMICAL ENGINEERING, JAN 2001.
/	E.	"BASICS OF THERMAL MASS FLOW CONTROL", UNIT INSTRUMENTS/KINETICS APPLICATION NOTE, JUNE, 1999.
	F.	"CURVE TRACKING AND POINT MATCHED", VISHAY INTERTECHNOLOGY, INC., DOCUMENT NO. 33005, MAY, 2000.
Examiner		Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (Modified)

Docket No. 378-21-011

Application Number
10/608,731INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Applicant: Craig A. Vincze, et al.

Filing Date 06/27/2003

Group Art Unit 2829

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number								Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number								Date	Country	Class	Subclass	Translation	
													Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	G.	"MASS FLOW CONTROLLER", STEC INC., SALES BROCHURE, 1996. (The year of publication is sufficiently earlier than the effective filing date and any foreign priority date.)

Examiner	Date Considered
----------	-----------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.